

THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
STEIMLE, ROBERT F., et al.

§ Patent No.: 6958265
§
§ Issue Date: 10/25/2005
§
§ Examiner: David A. Zameke
§
§ Group Art Unit: 2891
§
§

Application No.: 10/663621

Filed: 9/16/2003

Docket No.: SC12711TP

Title: SEMICONDUCTOR DEVICE WITH NANoclUSTERS

Certificate of Submission

I hereby certify that this correspondence is being submitted to the U.S.P.T.O., Alexandria, VA.

Addressed per C.F.R. § 1.1(a) and deposited with the United States Postal Service with sufficient postage as first class mail.

Facsimile transmitted in accordance with C.F.R. § 1.6(d).

Submitted electronically via EFS in accordance with "Legal Framework for EFS Web".

JANUARY 2, 2007

Date of Submission

Dora Hudgins

Signature

Dora Hudgins

Printed Name of Person Signing Certificate

Commissioner for Patents
Alexandria, VA 22313

SUBMISSION OF CERTIFICATE OF CORRECTION

Dear Commissioner:

Enclosed is a Certificate of Correction listing error(s) in the subject patent. Please enter these corrections. Since the errors appear to be on the part of the United States Patent Office, there should be no charge.

1/2/07
Date

Respectfully submitted,

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PATENT NO.: 6958265
APPLICATION NO: 10/663621
DATE: 10/25/2005
INVENTOR(S): STEIMLE, ROBERT F.

It is certified that error appears in the above-identified patent and that said Letters Patent are hereby corrected as shown below:

In Column 9, Line 16, Claim No. 6:

Change “suicide” to –silicide—

In Column 10, Line 6, Claim No. 19:

Change “C.” to –C— (remove period)

MAILING ADDRESS OF SENDER (Please do not use customer number below)

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